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PATENT  
Customer No. 22,852  
Attorney Docket No. 8071.0007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takeshi MITSUISHI et al.

Application No.: 09/986,907

Filed: November 13, 2001

For: COMPOSITION FOR VAPOR  
DEPOSITION, METHOD FOR  
FORMING AN ANTIREFLECTION  
FILM, AND OPTICAL ELEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

)  
)  
) Group Art Unit: 2872

)  
) Examiner: Joshua Pritchett

TECHNOLOGY CENTER 2800

JAN - 7 2004

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PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a one month extension of time to reply to the Office  
Action of August 26, 2003. A fee of \$110.00 is enclosed.

Please grant any extensions of time required to enter this response and charge  
any additional required fees to our deposit account 06-0916.

01/02/2004 BSAYAS11 00000098 09986907

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Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: December 24, 2003

By: Charles E. Van Horn  
Charles E. Van Horn  
Reg. No. 40,266

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